



10110002PS:187869

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of: )  
)  
Hiromichi Ohta, et al. ) Before the Examiner  
)  
Serial No. 09/615,883 ) Jennifer C. McNeil  
)  
Filed July 14, 2000 ) Group Art Unit 1775  
)  
) October 18, 2002  
)  
LOW-RESISTANCE ITO THIN )  
FILM AND METHOD FOR )  
MANUFACTURING SUCH )  
A FILM )

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231 on

October 18, 2002  
(Date of Deposit)  
Charles P. Schmal  
Name of Registered Representative  
Signature  
October 18, 2002  
Date of Signature

REQUEST FOR EXTENSION OF TIME

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Applicant's attorney requests that the date for responding to the Office Action dated May 20, 2002 be extended two (2) months to and including **October 20, 2002**.

The statutory fee of \$400.00 for this request is enclosed herewith. The Patent and Trademark office is authorized to charge any deficiency or apply any overpayment credit to Deposit Account No. 23-3030.

Respectfully submitted,

By

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